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**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2823**

**PATENT**  
Customer No. 22,852  
Attorney Docket No. 04329.2306

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Yoshio Ozawa et al. ) Group Art Unit: 2823  
Application No.: 09/559,757 ) Examiner: Pham, Thanh V.  
Filed: April 27, 2000 ) Confirmation No. 2923  
For: METHOD OF MANUFACTURING )  
A SEMICONDUCTOR DEVICE )  
USING AN OXIDATION PROCESS )

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR RECONSIDERATION AFTER FINAL**

In reply to the Final Office Action mailed January 11, 2005, the period for response extending through April 11, 2005, Applicants request the Examiner's reconsideration in view of the remarks that follow:

**Remarks** begin on page 2 of this paper.